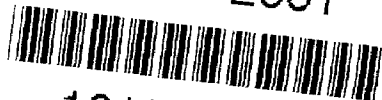


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US DEPARTMENT OF COMMERCE

To the Honorable Commissioner of Patents: Please record the attached documents or copy thereof.

1. Name of conveying party(ies):

T. H. Fedynyshyn, R. Sinta
R. R. Kunz
M. Sworin

7-30-01

Additional name(s) of conveying party(ies) attached? ☐ Yes ☐ No

3. Nature of conveyance:

☐ Assignment ☐ Merger
☐ Security Agreement ☐ Change of Name
☒ Other ☐ Confirmatory License

Execution Date(s):

13 July 2001

☒ This instrument should be recorded on the governmental register in accordance with 37 CFR 7.1(e)(1).

2. Name and address of receiving party(ies):

Name: UNITED STATES AIR FORCE

Internal Address: ESC/JAZ

Street Address: 40 WRIGHT STREET, BLDG 1120

City: HANSCOM AFB,

State: MA

Zip: 01731-2903

Additional name(s) & address(es) attached? ☐ Yes ☒ No

4. Application number(s) or patent number(s):

If this document is being filed together with a new application, the execution date of the application is:

A. Patent Application No(s):

09/791,252

B. Patent No.(s):

Additional numbers attached? ☐ Yes ☐ No

5. Name and address of party to whom correspondence concerning document should be mailed:

Name: Catherine A. Schulz

Internal Address: ESC/JAZ

Street Address: 40 Wright Street Bldg 1120

City: Hanscom AFB

State: MA ZIP: 01731-2903

6. Total number of applications and patents involved:

1

7. Total fee (37 CFR 3.41) \$ 0

☐ Enclosed ☒ Not Applicable

The instrument to be recorded is not an instrument affecting Title (37 CFR 7.1(e)(2) and (j)).

8. Deposit Account Number:

(Attach duplicate copy of this page if paying by deposit account)

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9. Statement and signature.

To the best of my knowledge and belief, the foregoing information is true and correct and nay attached copy is a true copy of the original document.

CATHERINE A. SCHULZ

Name of person signing

Catherine A. Schulz

Signature

24 July 2001

Date

Total number of pages including cover sheet, attachments and document:

2

CONFIRMATORY INSTRUMENT

Application for: "Low Absorbing Resists for 157nm Lithography"
Inventor(s): Theodore H. Fedynyshyn et al
M.I.T. Case No.: 99160L
Serial No.: 09/791,252 Date Filed: February 23, 2001
Grant/Contract No.: F19628-00-C-0002
Contractor: MASSACHUSETTS INSTITUTE OF TECHNOLOGY


The invention identified above is a "Subject Invention" under Patent Rights clause included in Contract Number F19628-00-C-0002 with the United States Air Force.

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The Government is hereby granted an irrevocable power to inspect and make copies of the above-identified patent application.

Signed this 13th day of July, 2001.

MASSACHUSETTS INSTITUTE OF TECHNOLOGY

By 
Deborah Burke
Patent Compliance Administrator
Technology Licensing Office

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